



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG835654986
Report verification at igi.org

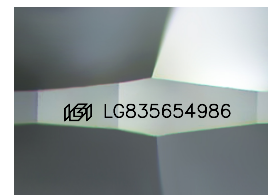
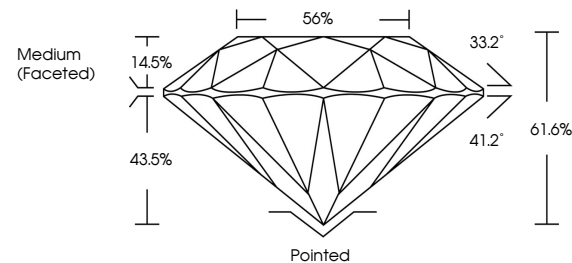
September 15, 2026	
IGI Report Number	LG835654986
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.22 - 8.26 X 5.07 MM
GRADING RESULTS	
Carat Weight	2.09 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG835654986

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

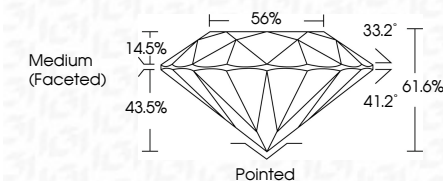
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



September 15, 2026	
IGI Report Number	LG835654986
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.22 - 8.26 X 5.07 MM
GRADING RESULTS	
Carat Weight	2.09 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG835554986
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES

www.igi.org

September 15, 2026
ICI Report No LG835654986
ROUND BRILLIANT

8.22 - 8.26 X 5.07 MM	Carat Weight	2.09 CARATS
	Color Grade	E
	Clarity Grade	VVS 2
	Cut Grade	IDEAL
	Depth	61.0%
	Table	56%
	Girdle	Medium (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Comments	1 carat/1 carat/1 carat

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.